In the claims:

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1. A system for sub-ambient pressure control for column head pressure in a gas chromatography (GC) system, comprising:

an inlet including:

5 a valve that regulates an inlet pressure;

a pressure sensor that measures the inlet pressure and outputs a signal that indicates a measured inlet pressure, wherein the inlet includes an inlet-pressure set-point that can be set to a negative pressure set-point representing a pressure below ambient pressure, the negative pressure set-point driving the valve to change the inlet pressure until the measured inlet pressure equals the negative pressure set-point; and

a capillary column connected to the inlet.

- 2. The system of claim 1, further comprising: a mass spectrometer (MS) connected to the capillary column.
- 3. The system of claim 1, wherein the inlet further includes:

an electronic pressure controller that drives the valve in response to the inletpressure set-point and the measured inlet pressure.

- 4. The system of claim 1, wherein the pressure sensor is a gauge pressure sensor.
- 5. The system of claim 1, wherein the GC includes instructions on a computerreadable medium for:

setting the inlet-pressure set-point to a negative pressure set-point; and driving the valve to change the inlet pressure until the measured inlet pressure equals the negative pressure set-point.

- 6. The system of claim 1, wherein the inlet includes an error amplifier that receives the measured inlet pressure signal and an inlet-pressure set-point signal and outputs a decreasing drive to the valve when the inlet-pressure set-point signal is less than the measured inlet pressure signal.
- 7. The system of claim 6, wherein the error amplifier outputs an increasing drive to the valve that causes the valve to increase the inlet pressure.
- 8. The system of claim 2, wherein the MS includes a vacuum pump connected to the capillary column.
 - 9. The system of claim 1, wherein the inlet further includes:

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a septum purge; and a cap on the septum purge.

10. The system of claim 1, further comprising: a computer, connected to the GC, including:

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a processor; and

a memory that includes instructions executed by the processor for:

setting the inlet-pressure set-point to a negative pressure set-point;

and

causing the valve to change the inlet pressure until the measured inlet pressure equals the negative pressure set-point.

- 11. The system of claim 1, wherein the gauge pressure sensor includes an offset (v_0) so that a measured inlet pressure of zero (0psig) causes the gauge pressure sensor to output a positive measured inlet pressure voltage (v_0) , where $v_0 > 0$ volts).
- 12. The system of claim 1, wherein the offset is 1 volt (v_0 = 1 volt).
- 15 13. The system of claim 1, wherein the offset is large enough to avoid the gauge pressure sensor inadvertently outputting a negative measured inlet pressure voltage.
 - 14. A method for sub-ambient pressure control for column head pressure in a gas chromatography (GC) system comprising:

receiving a desired negative pressure set-point representing a pressure below ambient pressure; and

setting an inlet pressure set-point to the desired negative pressure set-point, wherein the desired negative pressure set-point indicates a desired negative inlet pressure for an inlet of the GC.

15. The method of claim 14, further comprising:

reading a measured inlet pressure, wherein the measured inlet pressure is measured by a gauge pressure sensor in an inlet of the GC;

comparing the measured inlet pressure to the inlet pressure set-point; determining if the measured inlet pressure is greater than the inlet pressure setpoint; and

if the measured inlet pressure is greater than the inlet pressure set-point, decreasing the inlet pressure until the inlet pressure is a negative pressure matching the inlet pressure set-point.

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16. The method of claim 14, further comprising:

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if the measured inlet pressure is less than the inlet pressure set-point, increasing the inlet pressure until the inlet pressure is a negative pressure matching the inlet pressure set-point.

- 5 17. The method of claim 15, wherein the decreasing step includes causing a proportional valve in the inlet of the GC to decrease the inlet pressure.
 - 18. The method of claim 14, further comprising:
 setting a gauge pressure sensor offset (v_o) so that a measured inlet pressure of zero
 (0psig) causes a gauge pressure sensor to output a positive measured inlet pressure
 voltage (v_o, where v_o > 0volts).
 - 19. A computer-readable medium comprising instructions for sub-ambient pressure control for column head pressure in a gas chromatography (GC) system by:

receiving a desired negative pressure set-point representing a pressure below ambient pressure; and

- setting an inlet pressure set-point to the desired negative pressure set-point, wherein the desired negative pressure set-point indicates a desired negative inlet pressure for an inlet of the GC.
 - 20. The computer-readable medium of claim 19, further comprising instructions for: reading a measured inlet pressure, wherein the measured inlet pressure is measured by a gauge pressure sensor in an inlet of the GC;

comparing the measured inlet pressure to the inlet pressure set-point;

determining if the measured inlet pressure is greater than the inlet pressure setpoint; and

if the measured inlet pressure is greater than the inlet pressure set-point,

decreasing the inlet pressure until the inlet pressure is a negative pressure matching the inlet pressure set-point.

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